



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

September 22, 2025

IGI Report Number **LG735597832**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **PRINCESS CUT**

Measurements **8.78 X 8.73 X 5.95 MM**

GRADING RESULTS

Carat Weight **4.06 CARATS**

Color Grade **G**

Clarity Grade **VVS 2**

ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**

Symmetry **EXCELLENT**

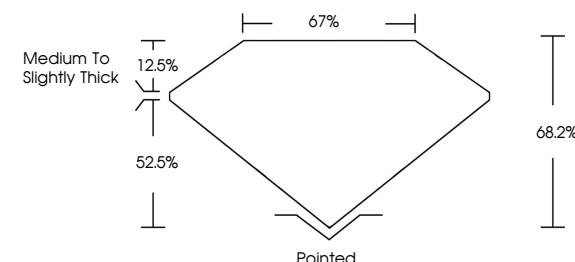
Fluorescence **NONE**

Inscription(s) **IGI LG735597832**

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.

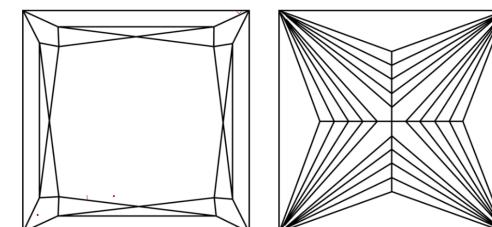
Type IIa

PROPORTIONS



Sample Image Used

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.

Green symbols indicate external characteristics.

www.igi.org

LG735597832
Report verification at igi.org

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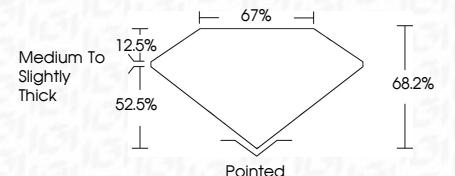
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September 22, 2025	IGI Report No. LG735597832
Princess Cut	
Carat Weight	4.06 CARATS
Color Grade	G
Clarity Grade	VVS 2
Depth	68.2%
Table	67%
Grade	Medium to Slightly Thick
Culet	Pointed
Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	IGI LG735597832

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IGI